

Notice of References Cited	Application/Control No. 09/895,689	Applicant(s)/Patent Under Reexamination LUO, HUITAO	
	Examiner Kevin Siangchin	Art Unit 2623	Page 1 of 1

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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